



# Approaching an optimum time resolution for synchroscan streak-camera measurements with visible synchrotron light

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Beijing, 12.09.2024



## 1. Introduction

- 1.1 BESSY II
- 1.2 BESSY II Beam Properties
- 1.3 Diagnostic Beamline
- 1.4 Streak Camera System Overview

## 2. Contribution to Resolution Broadening

- 2.1 Wavelength Independent Effects
- 2.2 Wavelength Dependent Effects

## 3. Resolution Studies

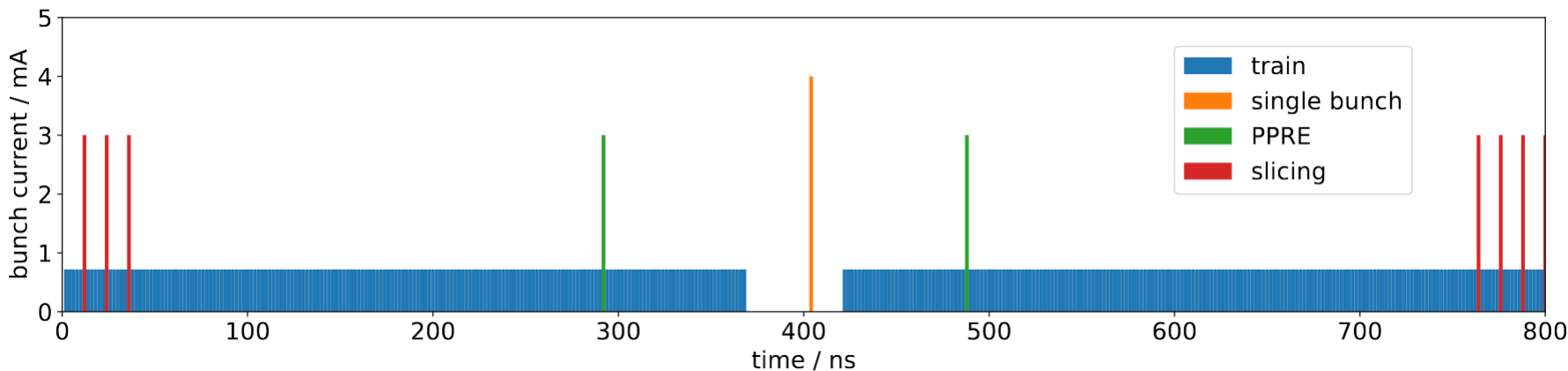
- 3.1 Simulations
- 3.2 Measurements

## 4. Conclusion

TopUp	Value
Beam Energy (GeV)	1.7
Rel. Energy Spread (%)	$7 \times 10^{-4}$
Beam Current (mA)	300
Beam emittance (nm)	5
Coupling (%)	2
H Beam size ( $\mu\text{m}$ )	64
V Beam size ( $\mu\text{m}$ )	47
RMS Bunch-length (ps)	20
Bunch Separation (ns)	2
Number of bunches/buckets	350/400
RF Frequency (MHz)	500
Bending Magnet Field (T)	1.3
Circumference (m)	240

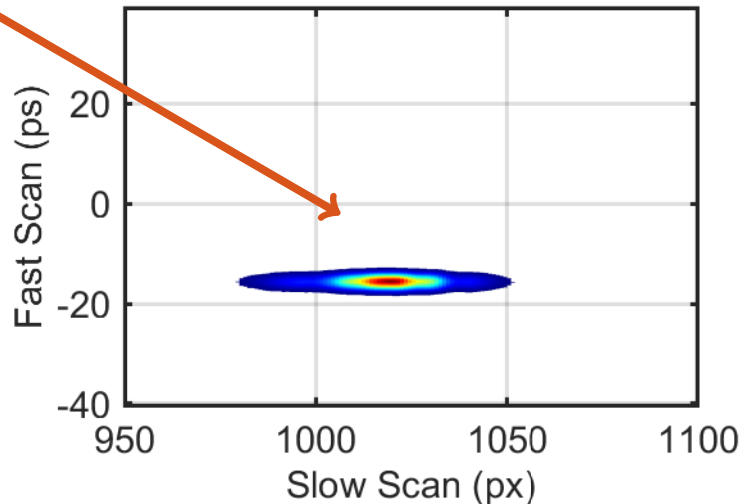
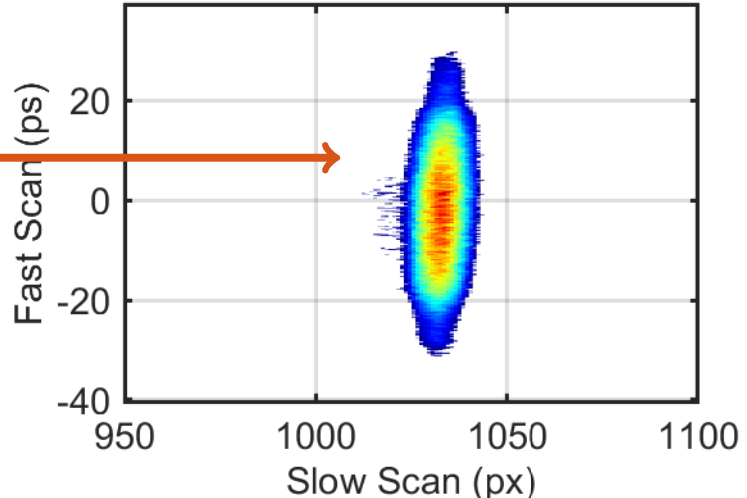


- slicing facility, superconducting wavelength shifter (x2), in-vacuum undulator
- hybrid filling pattern operation:
  - flux / brightness
  - brilliance ( $4 \times 10^{19}$  avg,  $6 \times 10^{21}$  peak)
  - timing / dynamics
- single bunch, few bunch
  - timing / dynamics
  - pulse length: 100 ps
- low-alpha: coherent THz radiation (timing ) 2 ps



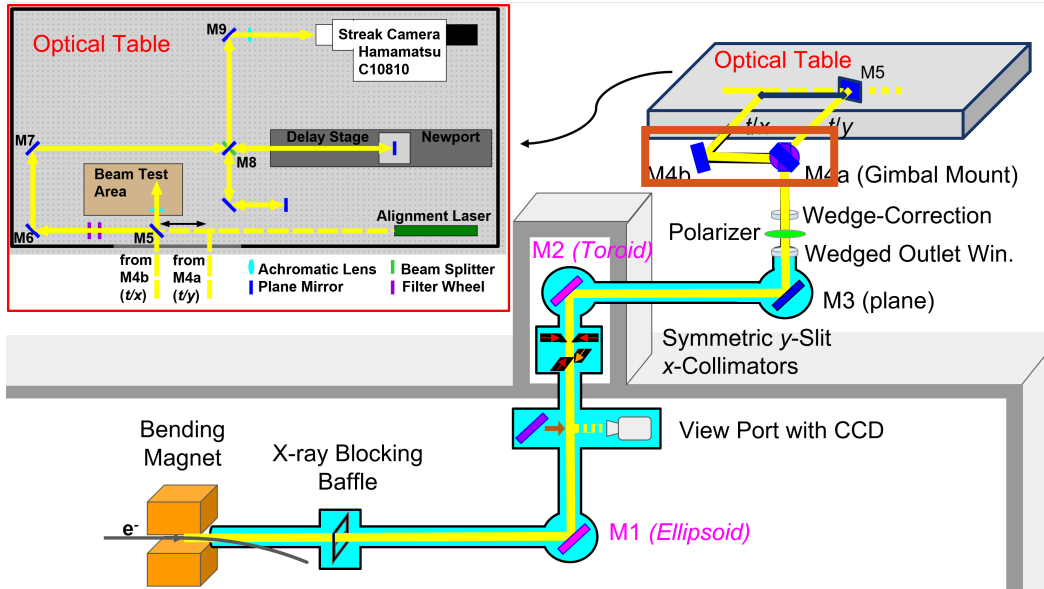
Standard Operation	Value
Beam Current (mA)	300
RMS Bunch-length (ps)	20
Emittance (nm)	5
$\alpha$	$7.3 \times 10^{-4}$

Low $\alpha$ Operation	Value
Beam Current (mA)	100
RMS Bunch-length (ps)	1
Emittance (nm)	40
$\alpha$	$3.5 \times 10^{-5}$



### Sub-ps resolution required:

- broadening in optical media
- broadening inside the streak-camera
- jitter broadening



Parameter	Value
Beam Energy	1.7 GeV
Bending Radius	4.35 m
Critical Energy	2.5 KeV

Opening angle 20x3.5 mm  
5.5 mW after X-Ray Blocker

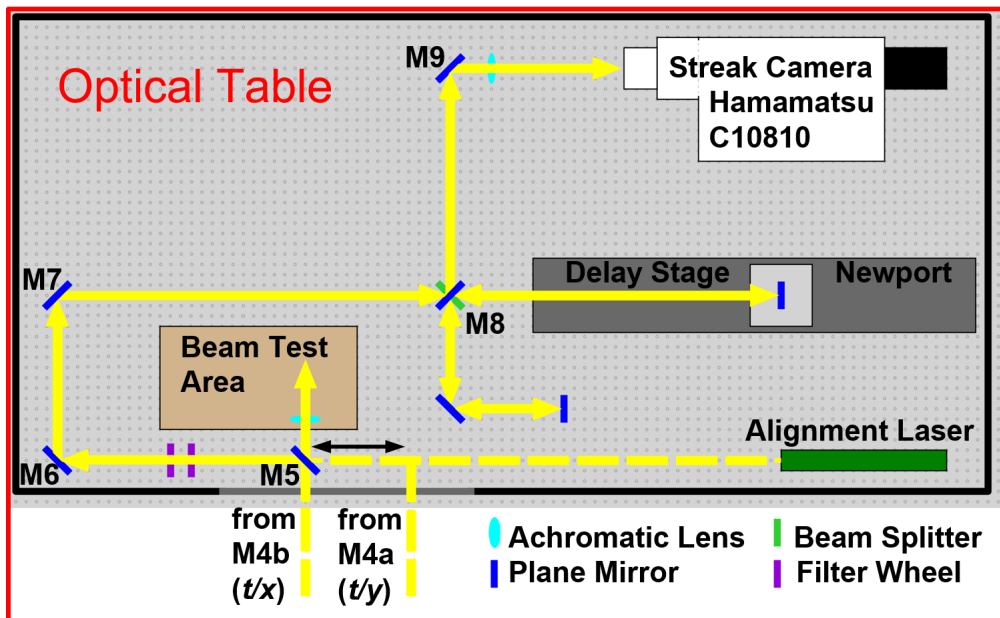
Zeiss ellipsoidal focusing mirror:  
intermediate focal point

WinlightX toroidal mirror:  
beam collimation

Wedge/anti-wedge window (3 mm fused silica);  $180^\circ \rightarrow$  position dispersion

Polarizer:  $\pi$ -polarized with X-Ray blocker

Gimbal mount mirrors: 2D additional info



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Gimbal mount mirrors: 2D additional info

2 Filter wheels: BPF and HP edge filters

Newport delay stage

Alignment laser

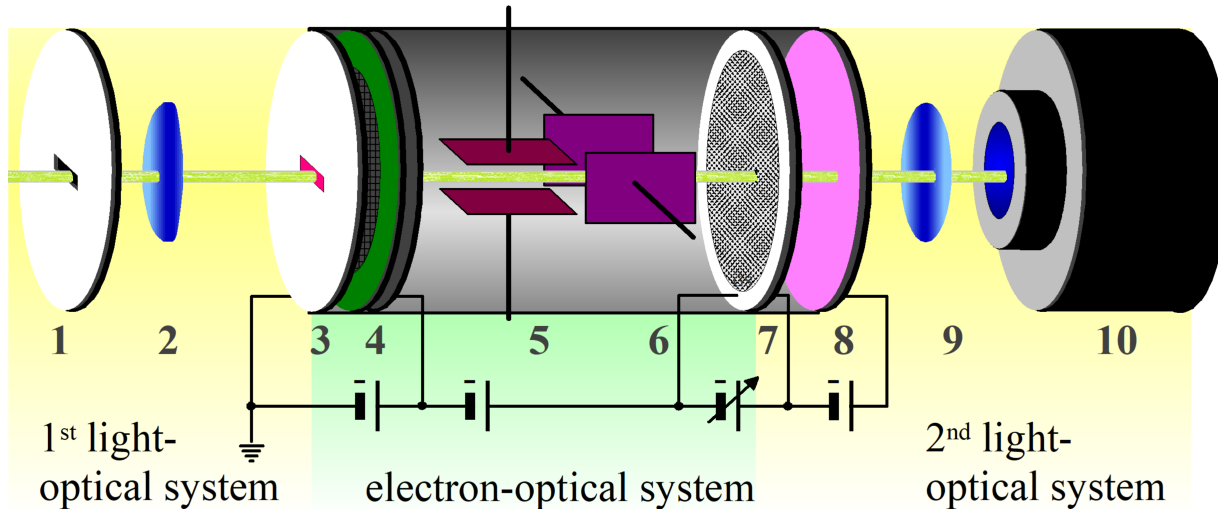
Achromatic lens: final focus

Hamamatsu C10810

5 m light path in the table

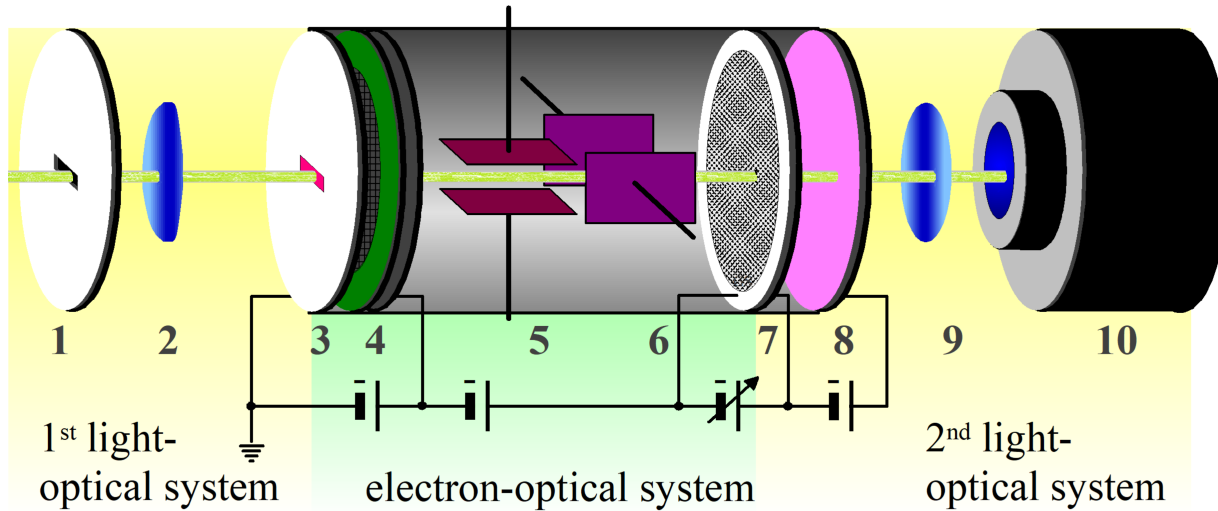
HQ plane mirror (surface flatness  $\lambda/20$ ):  
Good SNR → 1 to 2000 dynamic range

Maximize light and minimize dispersion:  
No beam splitters nor polarizer



OPTRONIS 500 MHz to  
125 MHz divider  
8 ns bunch distance

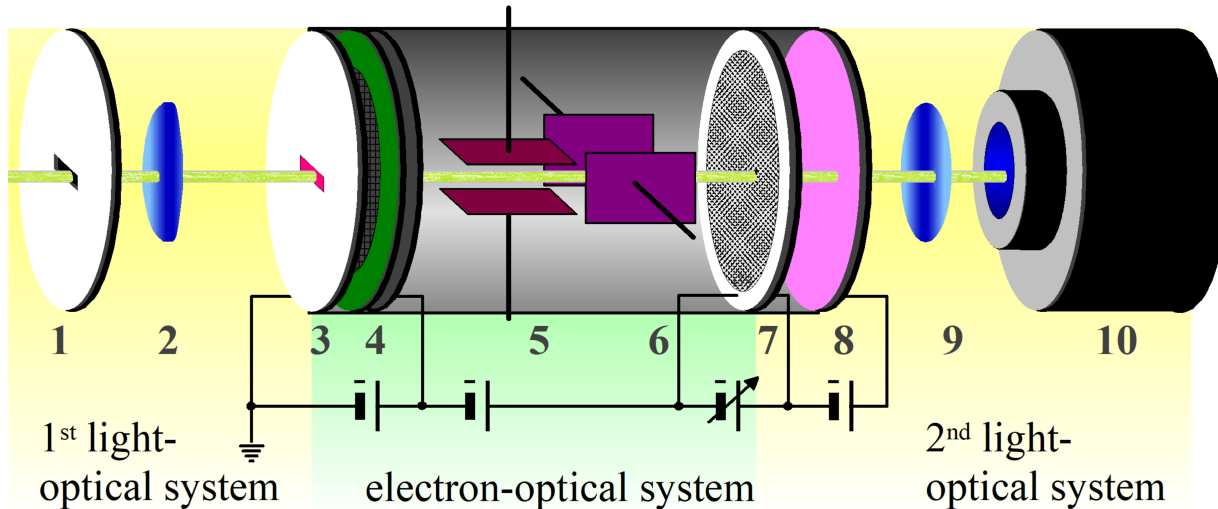
1. **Entrance slit:** 5 mmx14  $\mu$ m
2. **Lens:** focus on the cathode
3. **S-20ER Photocathode:** tx-type  $\rightarrow$  emits inside the tube
4. **Closely spaced mesh** to accelerate electrons and reduce dispersion
5. **V sweep electrodes:** vertical sweep with freq. 125 MHz
6. **H sweep electrodes:** slow saw-tooth type to separate individual bunches
- 7/8. **MCP/phosphor screen:** single-electron sensitivity with  $10^3$  to  $10^6$  photons per converted electron
- 9/10. **Detector system:** focus the light to the detector



OPTRONIS 500 MHz to 125 MHz divider  
Hamamatsu M10916-01 dual time-base unit: from 100 ns to 1  $\mu$ s at 1 kHz  
Sweep calib. via 3rd order poly: bunch structure for H, delay stage for V

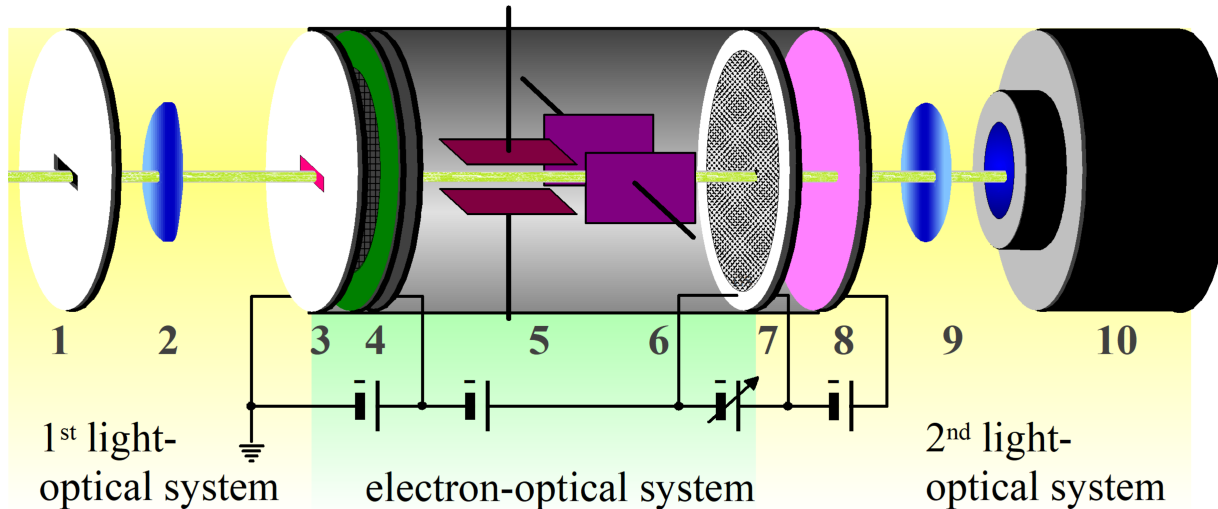
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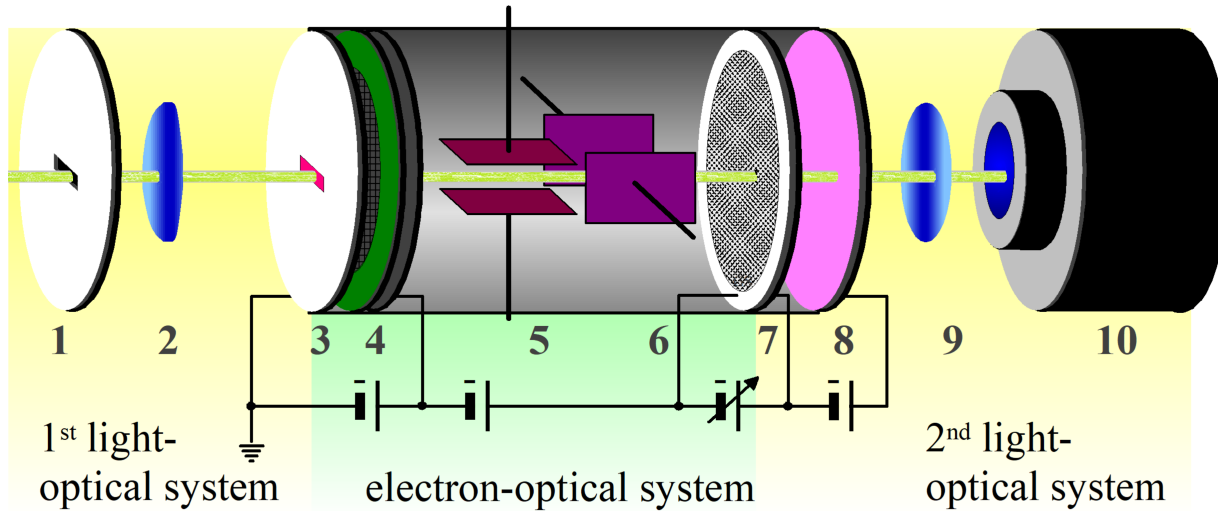
ORCA Flash 4.0 V3 CMOS  
with  $1344 \times 1016$  at 60 Hz

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Single-turn illumination or  
many-turns accumulation

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Continuous 1 kHz accumulation of 5000 frames with  $T_{exp} = 20$  ms: 100 s,  $10^5$  turns

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## Path-length Variation:

$-\beta_L \neq 1$

-Surface roughness and slope error

Uncertainty angle in wedge/anti-wedge vacuum window ( $\Delta\theta \approx 0.1^\circ$ ):

$$\Delta t_{wedge} = \sin(\Delta\theta) h_{beam} (n_{fs} - 1) / c$$

Mechanical vibration:

$$\Delta t_{vibration} = \Delta x_{vibration} / c$$

Air-damped legs  $\rightarrow$  vibration below 12 Hz

Parameter	RMS Value (fs)
$\Delta t_{beamline}$	< 1.3
$\Delta t_{wedge}$	5.5
$\Delta t_{vibration}$	13
$\Delta t_{air}$	< 20
$\Delta t_{slit}$	220
$\Delta t_{trigger}$	0 ... 295

## Time-delay Variation:

-Air pressure: 10 fs after few hours

-Convective air flow: minutes time scale

## Geometrical components:

$$\Delta t_{slit} = M \Delta y_{slit} \Delta t_{pixel} / \Delta y_{pixel}$$

## Trigger:

$$\Delta t_{RMS}^{trigger} = 0.145 ps [t_{acq}/s]^{0.154}$$

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$h_{beam} = 2 \text{ mm}$

$n_{fs} = 1.46$

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## Countermeasure:

Mild cooling (<2 K below exp. hall) at low air flux

Partial shielding of optical path

FSC as only power consumer

Test with hot-air gun

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$\Delta y_{slit} = 10 \mu m$ : ref value

$$M = 1.84$$

$$\Delta y_{pixel} = 6.5 \mu m$$

$$\Delta t_{pixel} = 78 \text{ fs in "Time Range 1"}$$

In operation  $\Delta y_{slit} = 14 \mu m$ : 63 fs additional broadening



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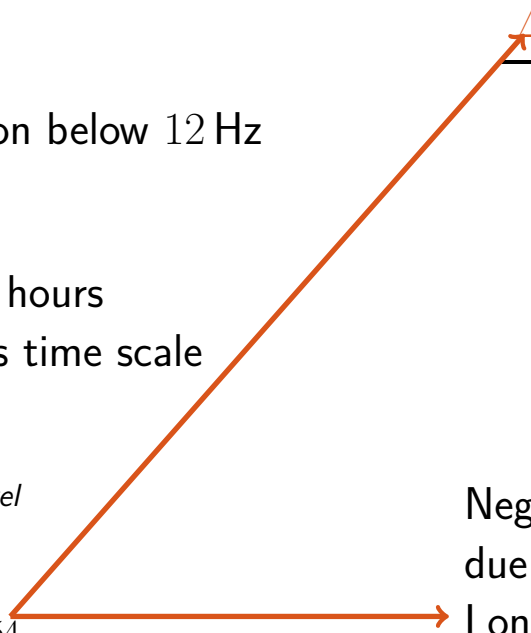
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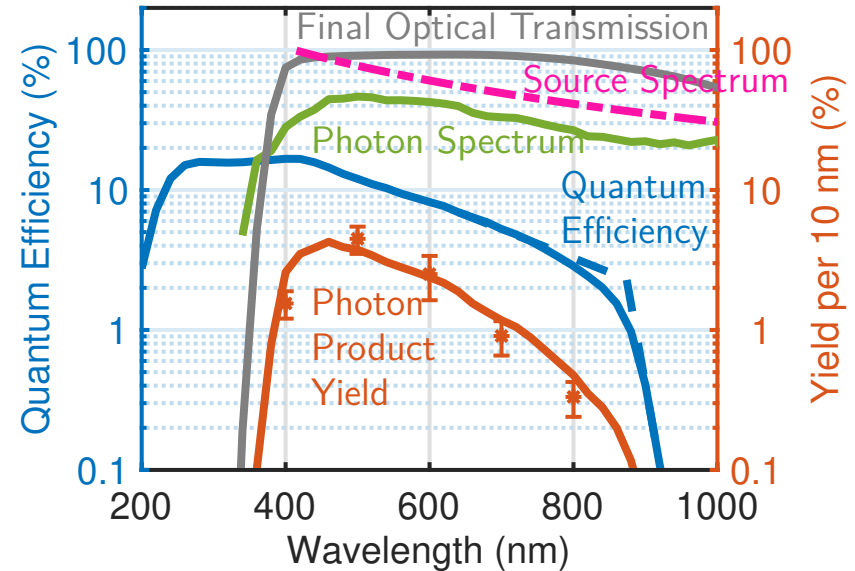


Negligible for  $T_{acq}$  less than 7 turns due to FSC PLL circuit

Longer time: noise spectrum and short-time drifts

Parameter	Value
Beam Energy	1.7 GeV
Dipole Magnetic Field	1.3 T

- **Source Spectrum:** Theoretical SR estimate for low frequency ( $\propto \lambda^{-4/3}$ )
- **Photon Spectrum:** Measured after M4 with spectrometer
  - losses at lower wavelength
- **Final Optical Transmission** coefficient at the streak camera entrance
  - Maximum at plateau of 90 %
  - Strong absorption losses below 400 nm
- **Quantum Efficiency** of the cathode (1)
  - $16.5 \pm 0.5 \%$  at  $\lambda = [270 - 440 \text{ nm}]$
  - asymptotic slope due to the Fermi edge
  - Work function  $\phi = 1.43 \text{ eV}$  at 0 K
- **Photon Product Yield:** product of photon spectrum with optical transmission and quantum efficiency.



(1) Hamamatsu test report

The Photon product yield will be used as wavelength dependent weighting

Max emission energy  $E_{max} = E_{photon} - \Phi$   
 To be added quadratically to 93 meV  
 Data point taken from (1)  
 Fit (dashed lines) used for timing simulation.

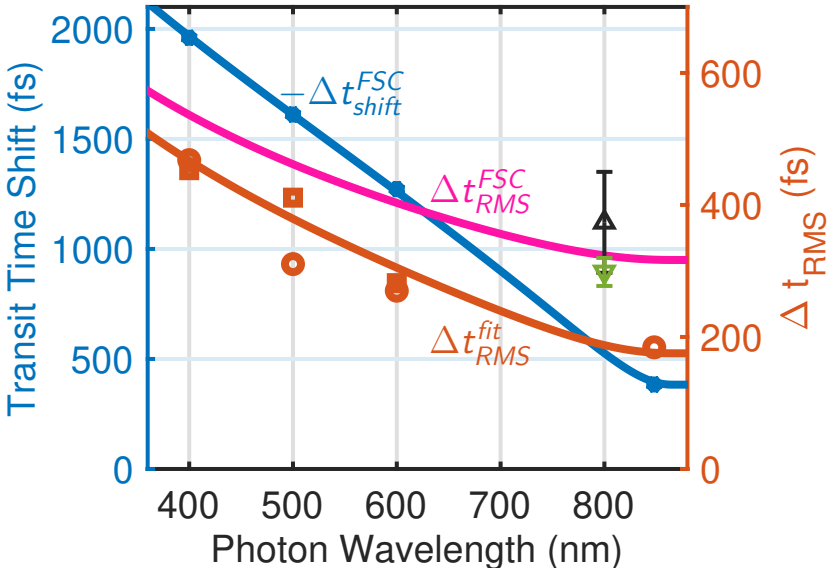
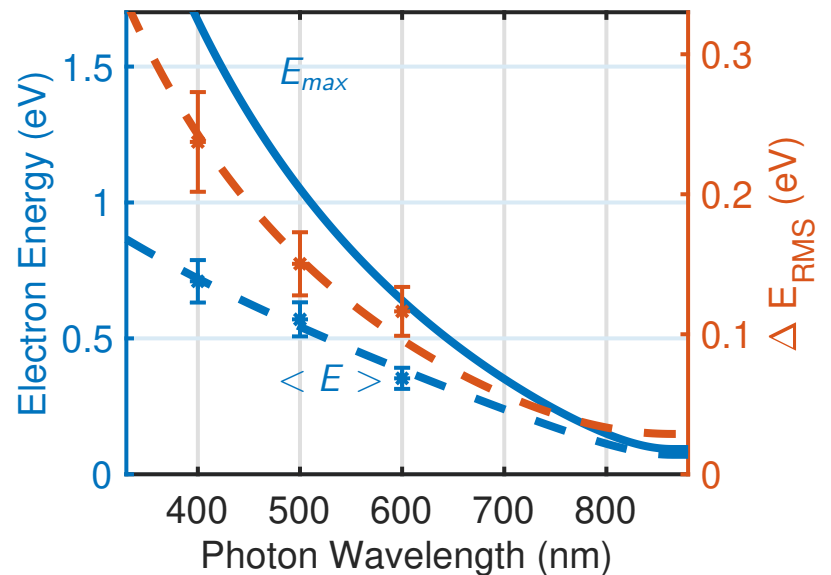
**Width:**

- (1) Data taken from Hamamatsu Paper (Squares)
- Relativistic Estimate (Circles)
- Laser Test at HZB (Triangles)
- Hamamatsu Laser Test (Triangles)

**Time Shift:**

Relativistic Estimate (asterisks)

$\Delta t_{RMS}^{FSC}$ : Quadratic some of  $\Delta t_{RMS}^{fit}$  with wavelength independent contributions (264 fs)



Peak shift and broadening of streak-camera time projections ( $\Delta t_{shift}^{OTS}$ ) due to thickness and  $n(\lambda)$ .

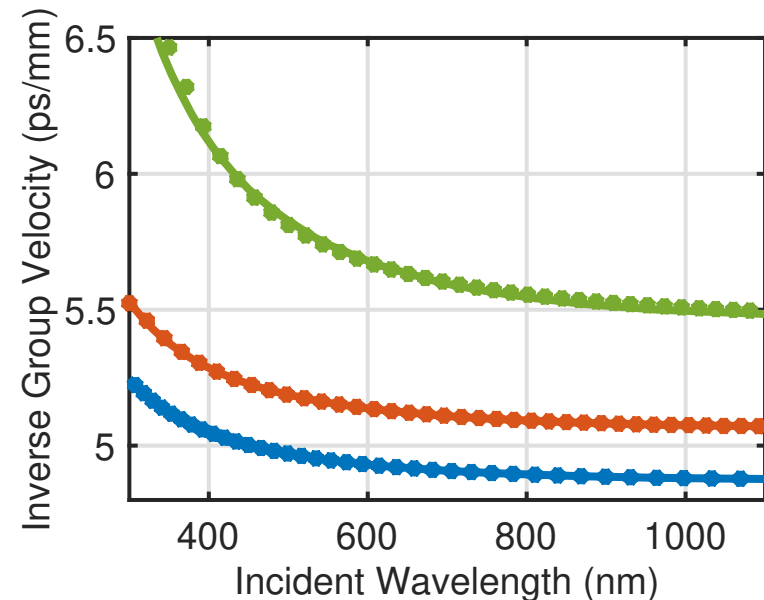
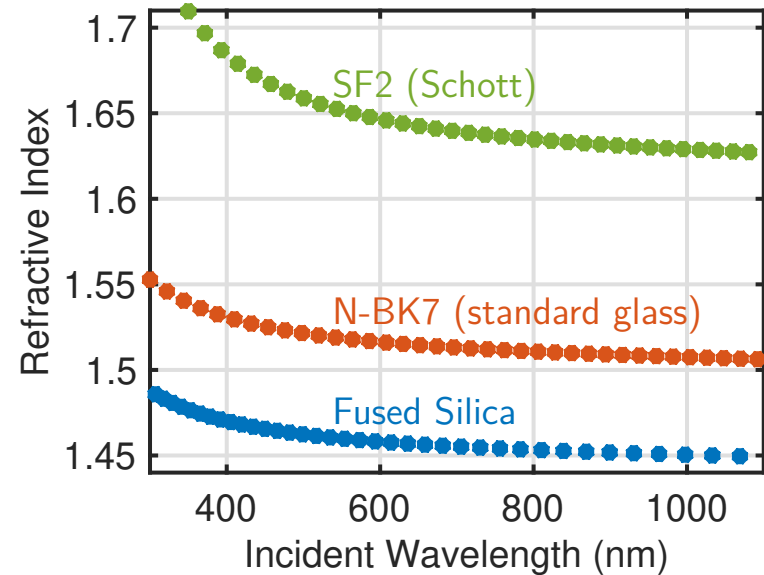
Anti-reflection Coating ( $<1$  mm) can be neglected.

$$\Delta t_{shift}^{OTS} = \sum_j l_j / v_{g,j}$$

1. Lack of data for several wavelength for several materials;
2. Only fuse silica is well documented;
3. Find scaling properties to infer the missing data.

$$\frac{1}{v_{g,j}} = P_{1,j} \left( \frac{\partial K}{\partial \omega} \right)_{Silica} + P_{2,j}$$

Material	$P_1$	$P_2$ (ps/mm)
N-BK7 (std glass)	1.245	-0.803
SF2 (Schott)	3.673	-3.384
Soda Lime	1.200	-0.630
SF5 (Schott)	4.086	-3.516



White-light through optics of only silica.  
 $t_{acq} \ll 5 \mu s \rightarrow$  FSC phase-lock suppress external trigger-jitter.

**Deterministic Simulation**  $\rightarrow$  due to  $\Delta t_{shift}^{OTS}$  and  $\Delta t_{shift}^{FSC}$ :

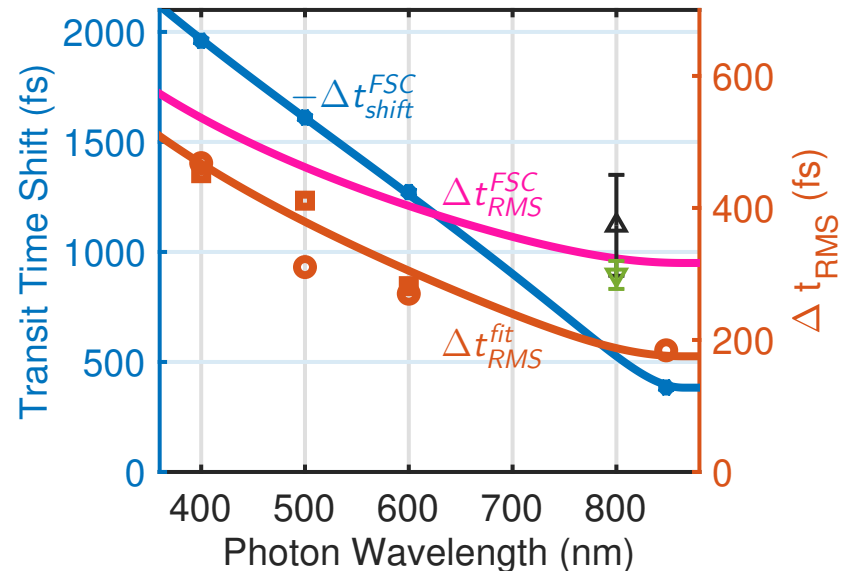
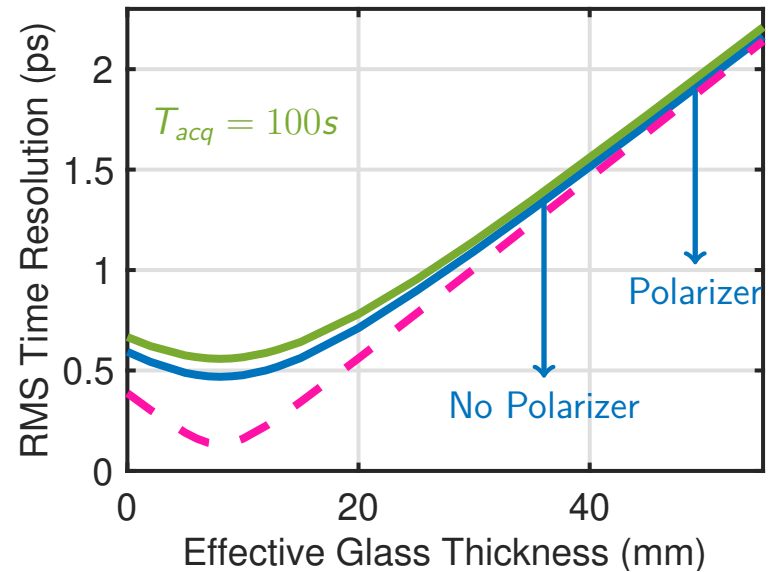
- Min due to delay-time cancellations at 8 mm;
- Min  $\neq 0$  due to wavelength dependencies.

**Full Simulation**  $\rightarrow$  includes also  $\Delta t_{RMS}^{FSC}$ :

- Significant effects below 16 mm;
- Above 18 mm  $\Delta t_{shift}^{OTS}$  is dominant.
- S.O.: 47 mm  $\rightarrow$  1.8 ps RMS.
- wo Pol.: 34 mm  $\rightarrow$  1.3 ps RMS.

**Long Acquisition Time**  $\rightarrow$  additional trigger jitter contribution

$$\Delta t_{RMS}^{trigger} = 0.145 ps [t_{acq}/s]^{0.154}.$$



- Low current (850 nA)  $\rightarrow$  negligible collective effects
- $\alpha \rightarrow 0$ : small bunch length
- 336 buckets filled with uniform filling pattern
- $t_{acq} = 100 \text{ s} \rightarrow \Delta t_{RMS}^{trigger} = 295 \text{ fs}$
- BPF at 700 nm with BW of 50 nm

$$\sigma_t = 881 \pm 2 \text{ fs}$$

$$\sigma_t = 895 \pm 2 \text{ fs}$$

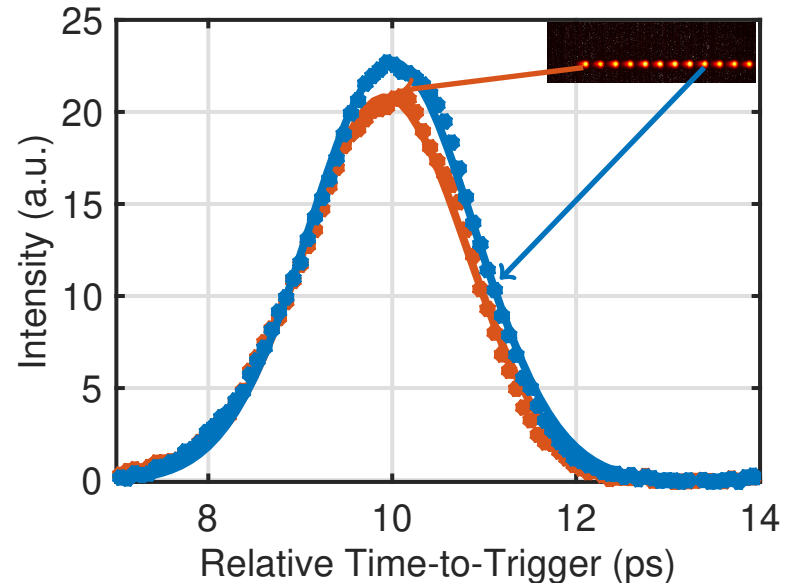
Mean bunch length of 894 fs

Relative variation of 1.5 %

Position variation below 40 fs

Edmund BPFs 3.5 mm thick

Thorlabs FELH edge filters 2 mm thick



BW of 10 nm at 400, 500, 600 and 700 nm  
and BW of 50 nm at 700 nm

Cut-off frequency of 500, 600 and 700 nm

## Delay Time:

Depends only on time shift on FSC and OTS  
 Simulation and experiment agrees  
 Difference due to filter thickness

## Pulse Width:

Dashed curves  $\rightarrow$  time resolution

Blue  $\rightarrow \Delta t_{RMS}^{FSC}$

Red  $\rightarrow$  also  $\Delta t_{shift}^{FSC}$  and  $\Delta t_{shift}^{OTS}$

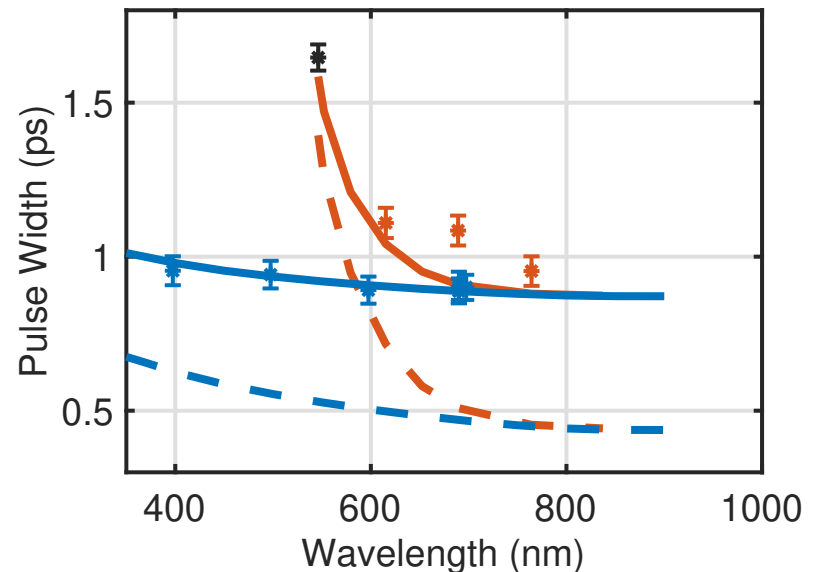
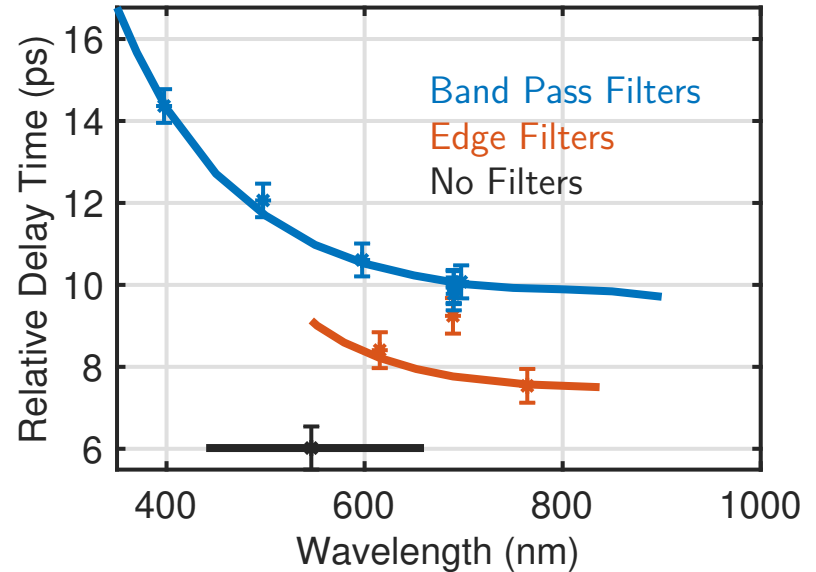
$\Delta t_{RMS}^{bunch} = 0.75 \pm 0.01$  ps  $\rightarrow$  spectroscopy of coherent THz

### 600 nm Edge filter:

No defect at optical inspection  
 hyp.: resonance-like delay and broadening effect

### Edge filter:

6%  $\rightarrow$  hyp.: neglected higher order effects

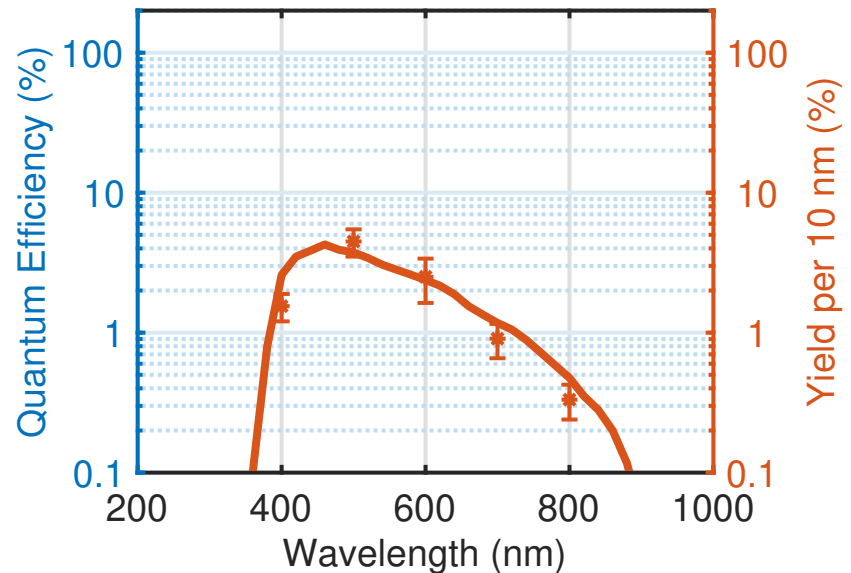
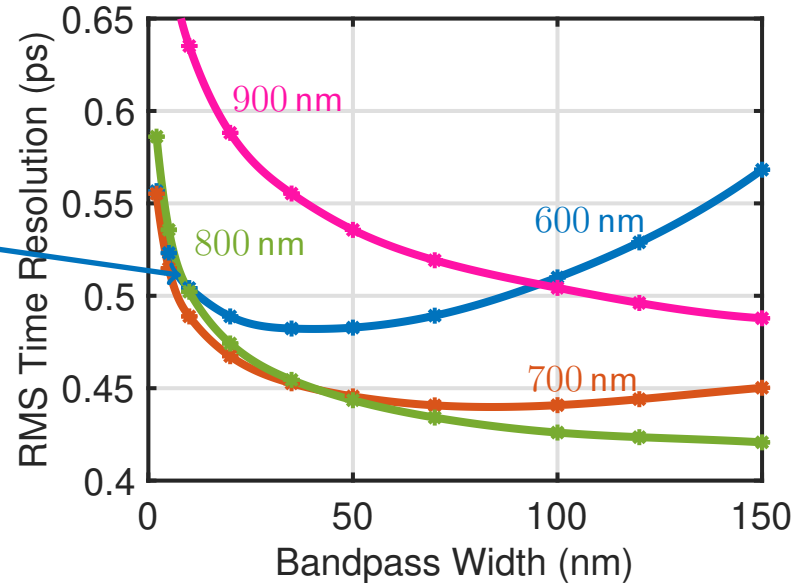


Several BPF simulated  
 Filtered photon flunce constant  $\rightarrow$  increased  $T_{acq}$  and  $\Delta t_{RMS}^{trigger}$   
 10 nm at 600 nm with  $T_{acq} = 100$  s  $\rightarrow$  reference value

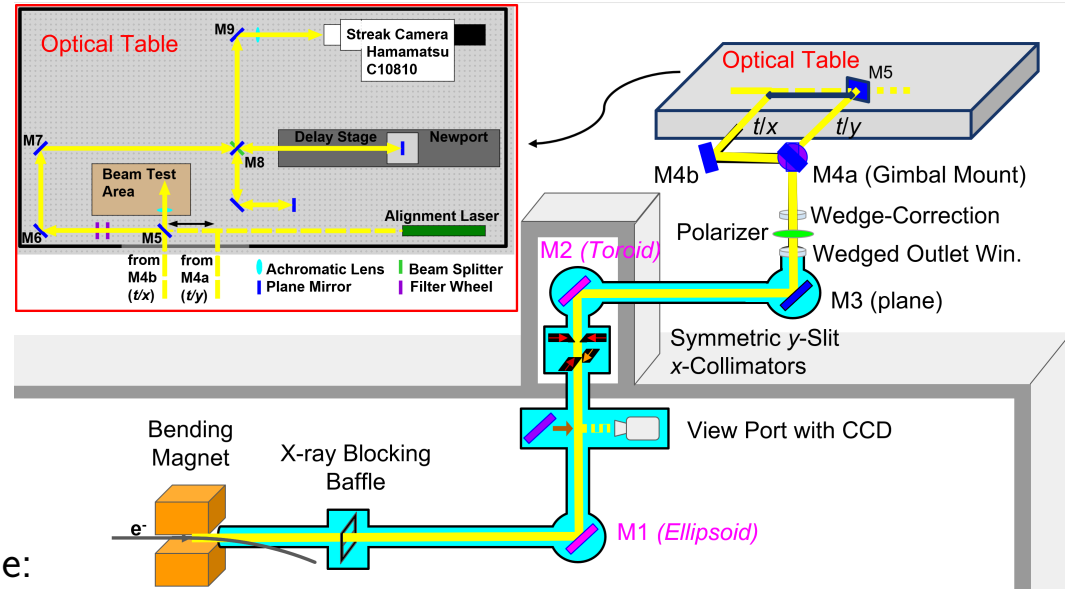
Left side  $\rightarrow$  increased jitter and resolution  
 Higher  $\lambda$  and  $\Delta\lambda_{bp}$  is better

900 nm is worst  $\rightarrow$  jitter dominated

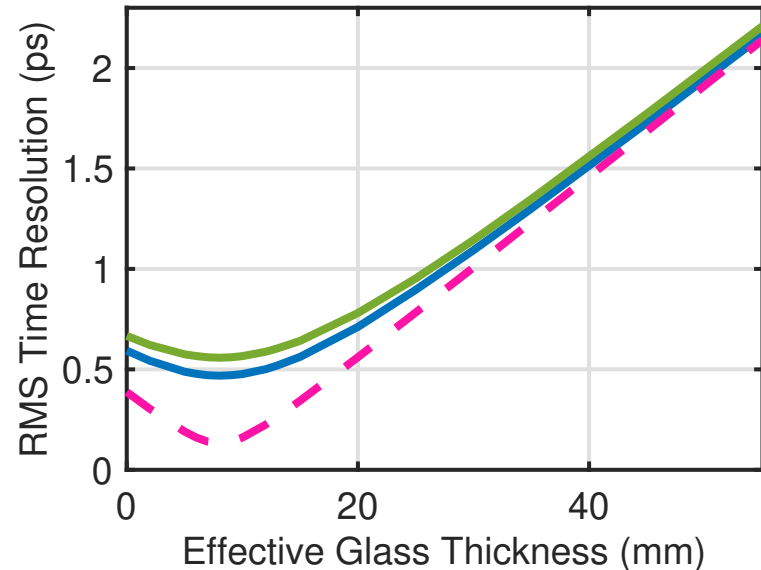
Best for 150 nm at 800 nm  $\rightarrow$  0.42 ps  
 Such high quality filter does not exist  
 Best obtained is 0.47 ps at 700 nm



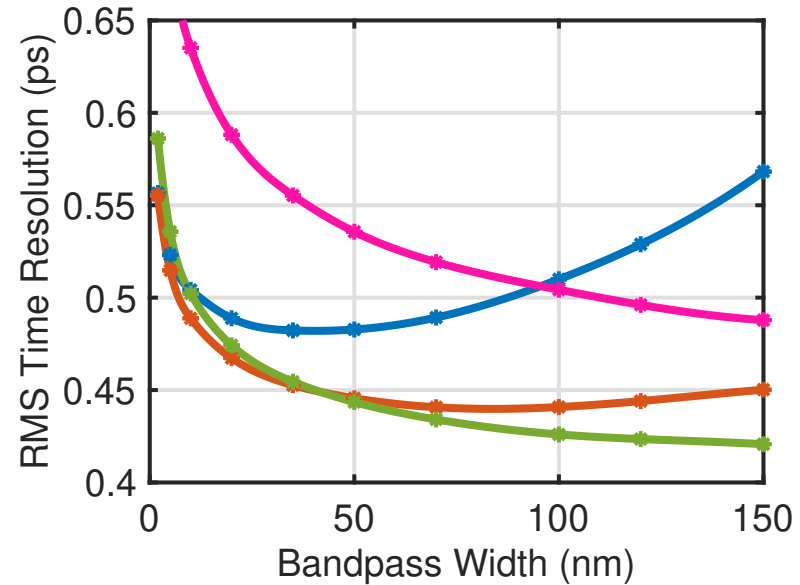




- Characterization of the beamline:
  - Optical media
  - Streak camera
- Analysis of broadening mechanism:
  - find major source of broadening
  - improve resolution
- 1.3 ps resolution obtained (single-shot with white-light)
- 0.47 ps resolution obtained (long acquisition time)
- 0.4 ps potentially achievable with a BPF of 150 nm BW at 800 nm.



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- 0.47 ps resolution obtained (long acquisition time)
- 0.4 ps potentially achievable with a BPF of 150 nm BW at 800 nm.

<https://doi.org/10.1016/j.nima.2024.169196>

- Hardware developments for the timing beamline:
  - Th. Zeschke from HZB
  - R. Fleischhauer from HZB
  - O. Pawlizki from HZB
  - I. Müller from HZB
  
- Software support:
  - Th. Birke from HZB
  - I. Seiler from HZB
  
- Incorporation of realistic time structures into the ray-tracing code RAY-UI:
  - P. Baumgärtel from HZB
  
- Very helpful discussions and information:
  - I. Grill from the Hamamatsu support group
  - Th. Franzl from the Hamamatsu support group